

# NIL Industrial Day (May 02-03, 2017) - Program

## May 2nd, 2017 ~ NIL Industrial Day (part 1)

11:00 - 12:30 Registration / Networking and Exhibition

12:15 - 12:30 Welcome and Introduction



### 12:30 - 14:30 Session I - Nanopatterning Applications in Life-Sciences & Photonics

City University of Hong Kong (HKG), Stella W. Pang  
University Hamburg UHH (GER), Irene Fernandez-Cuesta  
DTU Nanotech (DEN), Anja Boisen  
micro resist technology GmbH (GER), t.b.d.  
University of Eastern Finland UEF (FIN), Janne Laukkanen

### 14:30 - 15:30 Networking and Exhibition

### 15:30 - 17:10 Session II - Industrial Nanopatterning: Solutions

Institute of Materials Research and Engineering IMRE (SIN), Karen Chong  
Toshiba Machine Co. Ltd. (JPN), Hiroshi Goto  
Süss MicroTec AG (GER), Eleonora Storage  
Philips SCIL Nanoimprint Solutions (NED), Marc Verschuuren  
EV Group (AUT), Martin Eibelhuber

### 17:30 Dinner and Networking Event

## May 3rd, 2017 ~ NIL Industrial Day (part 2)

08:00 - 09:00 Networking and Exhibition

### 09:00 - 10:40 Session III - Industrial Nanopatterning: Production

CEA Leti (FRA), Stefan Landis  
AMO GmbH (GER), Florian Schlachter  
Sunpartner Technologies (FRA), Badre Kerzabi  
Nanotypos (GRE), Theodoros Tachtsidis  
NIL Technology ApS (DEN), Theodor Nielsen

### 10:40 - 11:30 Networking and Exhibition

### 11:30 - 13:10 Session IV - Future Vision & Associated Technologies

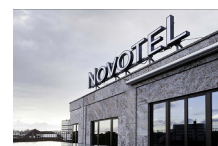
Profactor GmbH (AUT), Michael Mühlberger  
Simprint (USA), Hayden Taylor  
Paul-Scherrer-Institut PSI (SUI), Helmut Schiff  
PIXDRO (NED), t.b.d.  
Waseda University Tokyo (JPN), Jun Mizuno

### 13:10 - 15:00 Luncheon, Networking and Exhibition

15:00 Fare-well

End of NIL ID 2017

Novotel Berlin  
Am Tiergarten  
Straße des 17. Juni 106  
10623 Berlin



[www.novotel.com](http://www.novotel.com)

Local organizer:

micro resist technology GmbH  
Köpenicker Straße 325  
12555 Berlin - Germany  
[www.microresist.com](http://www.microresist.com)



Commercial exhibition:

Day 1 - 11:00 - 18:00

Day 2 - 08:00 - 15:00